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Typed or Printed Name of Person Mailing Paper or Fee: Shirley Fajardo

Signature: Shirley Fajardo

PATENT
Docket No. P1572

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): JENNIFER WANG
HUI-MIN SHENG
MIKE BARSKY

SERIAL NO.: 10/782,723 EXAMINER: UNKNOWN

FILED: FEBRUARY 18, 2004 ART UNIT: 1765

FOR: DRY ETCHING PROCESS FOR COMPOUND SEMICONDUCTORS

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

In connection with the above-referenced patent application, transmitted herewith are
the following:

1. Status Inquiry Letter (1 page); and
2. Post card in acknowledgment of receipt of all transmitted materials.

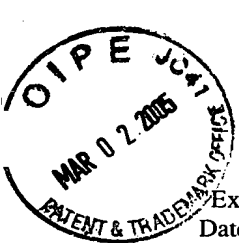
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Respectfully submitted,



May Lin DeHaan
Reg. No. 42,472

MLD/pa
Date: 3/2/05
LARIVIERE, GRUBMAN & PAYNE, LLP
P.O. Box 3140
Monterey, CA 93942-3140
(831) 649-8800



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STATUS INQUIRY LETTER

Dear Sir:

Please advise as to the status of this application. In particular, please inform us as to when the Examiner expects to take this case up for action. The most recent document received from the Patent Office is the Filing Receipt dated June 14, 2004.

Respectfully submitted,

May Lin DeHaan

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Reg. No. 42,472

MLD/pa
Date: 3/2/05
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Monterey, CA 93942
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